



**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**
Form PTO-1449 (Modified)
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COMPLETE IF KNOWN

Application Number	10/617,578
Confirmation Number	3549
Filing Date	July 11, 2003
First Named Inventor	Steven P. Nally
Group Art Unit	1763
Examiner Name	(to be assigned)
Attorney Docket No.	108298533US1

Sheet 1 of 1

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No.	U.S. Patent or Application		Name of Patentee or Inventor of Cited Document	Date of Publication or Filing Date of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		NUMBER	Kind Code (if known)			
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Examiner Initials*	Cite No.	Foreign Patent or Application			Name of Patentee or Applicant of Cited Document	Date of Publication or Filing Date of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T
		Office	NUMBER	Kind Code (if known)				
WAG		JP	59-175751	A	Mori et al.	10/04/1984		
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OTHER PRIOR ART-NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume issue number(s), publisher, city and/or country where published.	T
WAG		"Abrasive Blasting Media," McMaster-Carr, p. 2274, < http://www.mcmaster.com >. <i>no date avail</i>	
		VAN ZANT, PETER, <i>Microchip Fabrication, A Practical Guide to Semiconductor Processing</i> , Chapter 18, pp. 557-593, 4 th Edition, McGraw-Hill, New York, February 2000, ISBN 0071356363.	

EXAMINER

Wita Jlewer

DATE CONSIDERED

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*EXAMINER: Initial if reference considered, whether or not criteria is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to application(s).